

Thin liquid lithium targets for high power density applications: heavy ion beam strippers and beta beam production

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Outline

- Liquid Lithium Stripper idea for FRIB
- Brief theory of film stability
- Hardware description
- Status before FRIB
- Improvements for FRIB
- E-beam thickness measuring system
- Thickness measurement results
- Next Steps
- Beta-beams



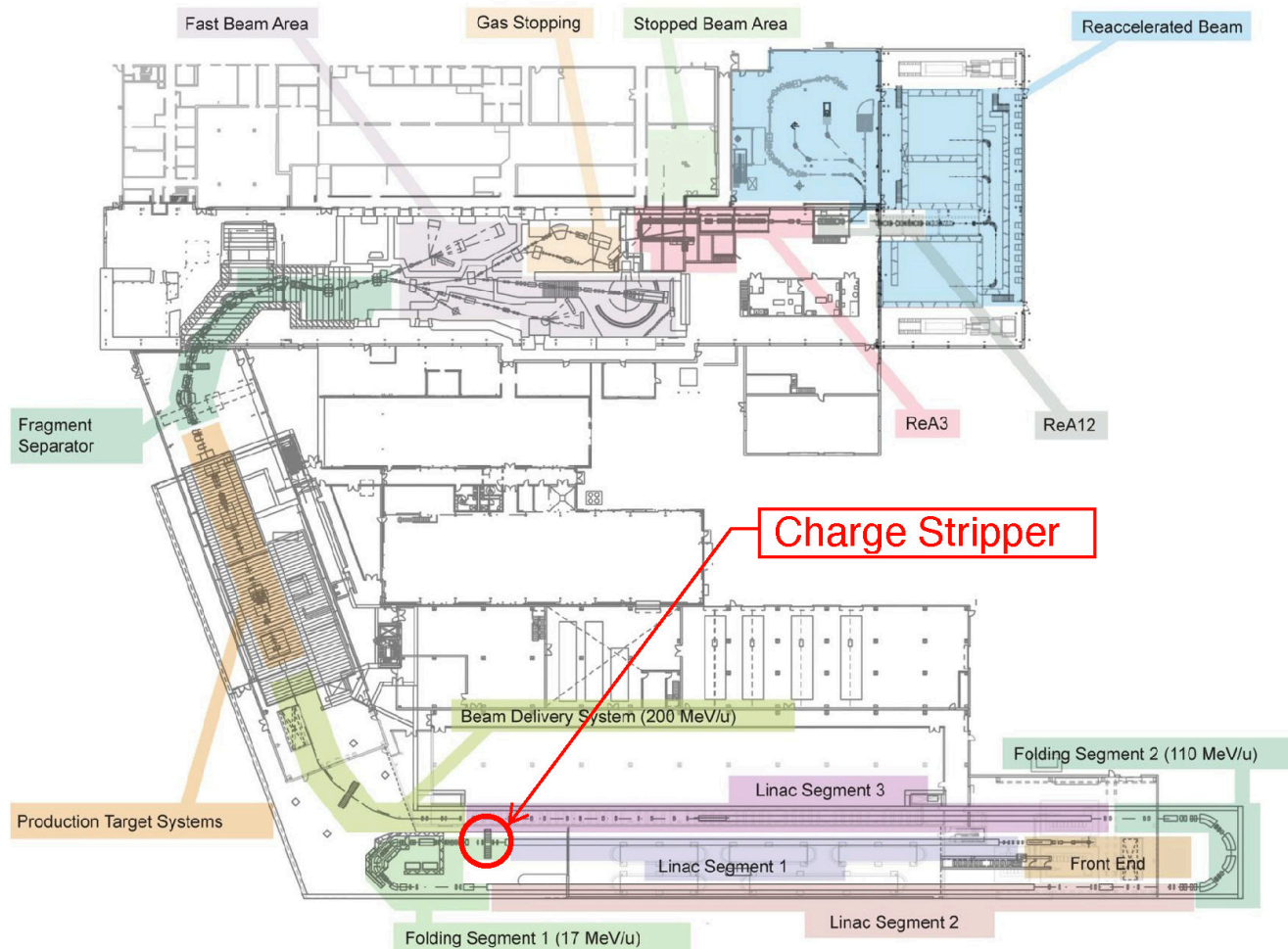
Liquid Lithium Stripper for FRIB:

Advantages

- High charge state
- High velocity flow ~ 60 m/s
- High heat capacity of Li
- Absorbs power deposited by the heavy ions
 - $P \sim 600$ W to ~ 1000 W
 - $\Delta T \sim 150$ to ~ 420 °C
- May have unlimited lifetime



CD-1 Conceptual Design – [2]



FRIB



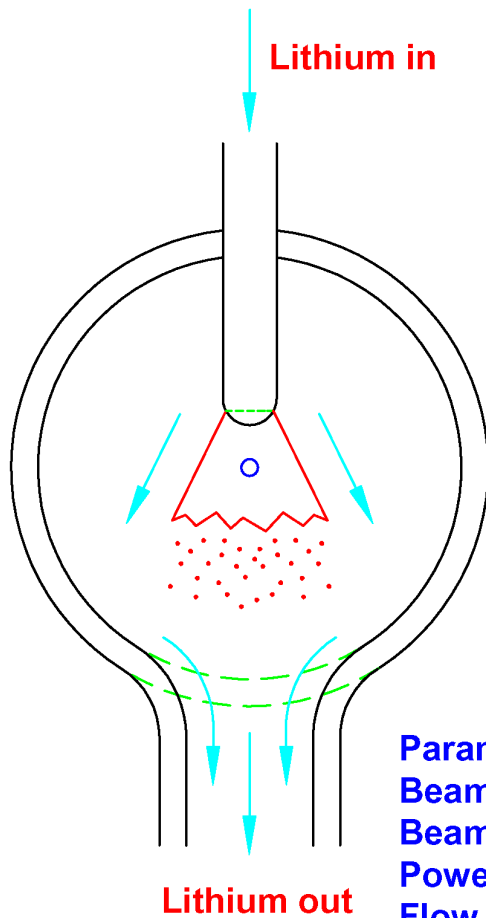
Facility for Rare Isotope Beams
U.S. Department of Energy Office of Science
Michigan State University

T. Glasmacher, FRIB Update NSAC, 8 Dec 2010, Slide 19

Concept for FRIB Thin Liquid Lithium Stripper Film

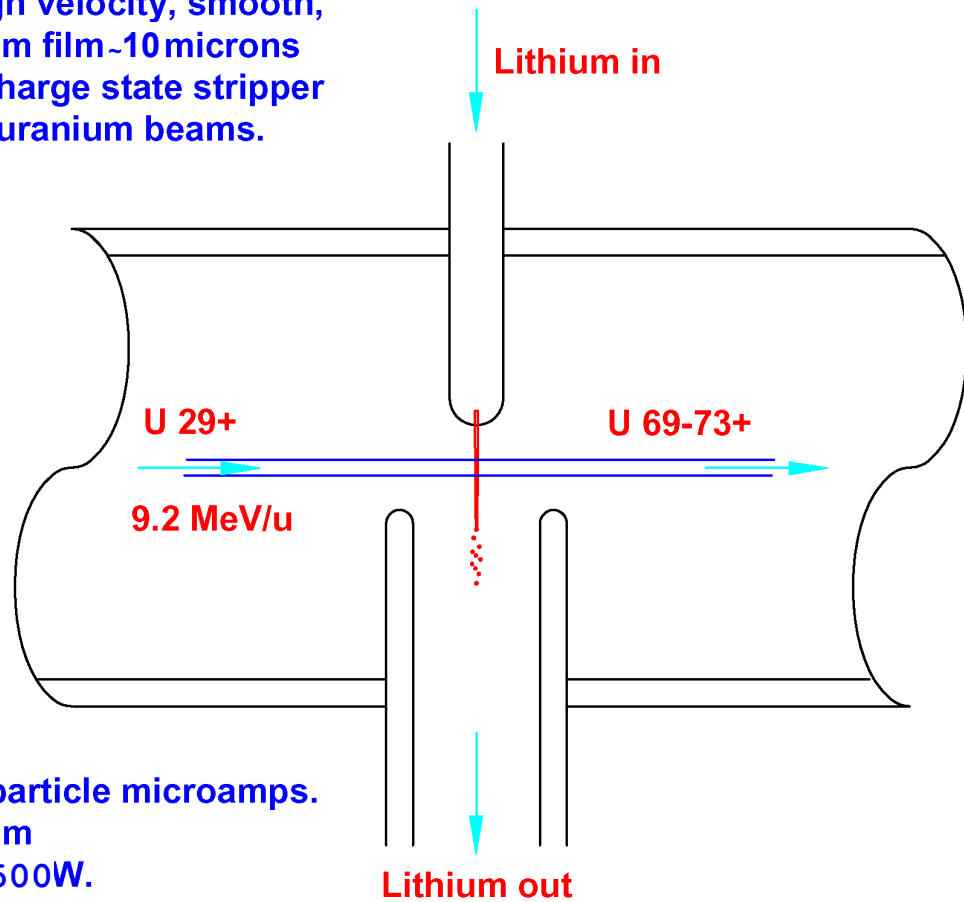
Problem:

Develop high velocity, smooth, stable lithium film ~10 microns thick as a charge state stripper for intense uranium beams.



Parameters:

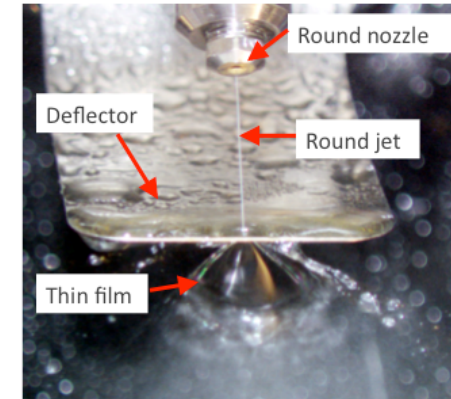
Beam current: 1.5 particle microamps.
Beam diameter 1 mm
Power deposited ~500W.
Flow velocity: ~60 m/s.
Peak temperature rise: ~400 C.



Introduction

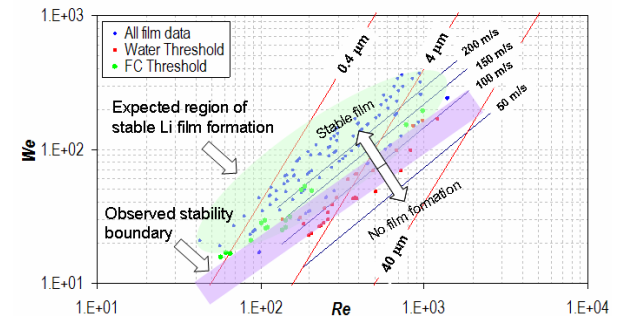
- Development of a thin liquid lithium film is divided into three steps:

1. Experimentally develop a liquid thin film formation scheme,



2. Experimentally develop of a film stability diagram for the film production scheme using water & a fluorocarbon liquid,

This diagram will provide the range of design parameters, such as film thickness and velocity, that are potentially capable of producing a stable, smooth liquid lithium film.



3. Experimentally demonstrate formation of a thin film liquid lithium jet and confirm that the film is appropriate to be used as a stripper (thickness, film stability, size, and velocity etc).



Introduction

Approach to thin film production

- Forces on flowing Li film in vacuum:
 - Inertia (IF)
 - Surface tension (SF)
 - Viscosity (VF)
- Reynolds number (Re) $\sim IF/VF$
- Weber number (We) $\sim IF/SF$
- Empirically determine film stability in We vs Re plane

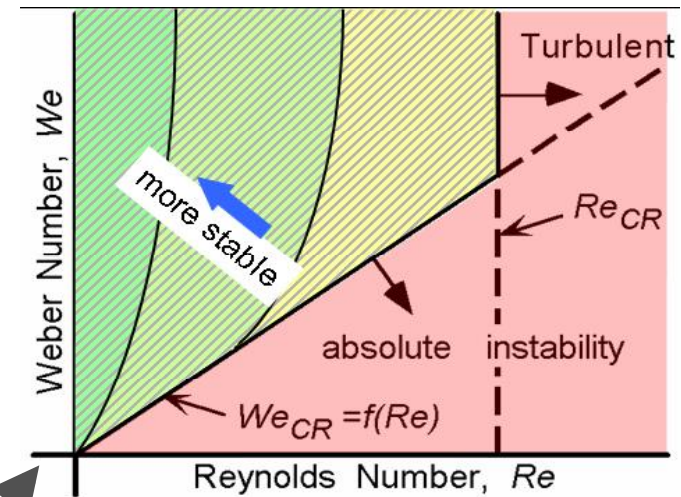
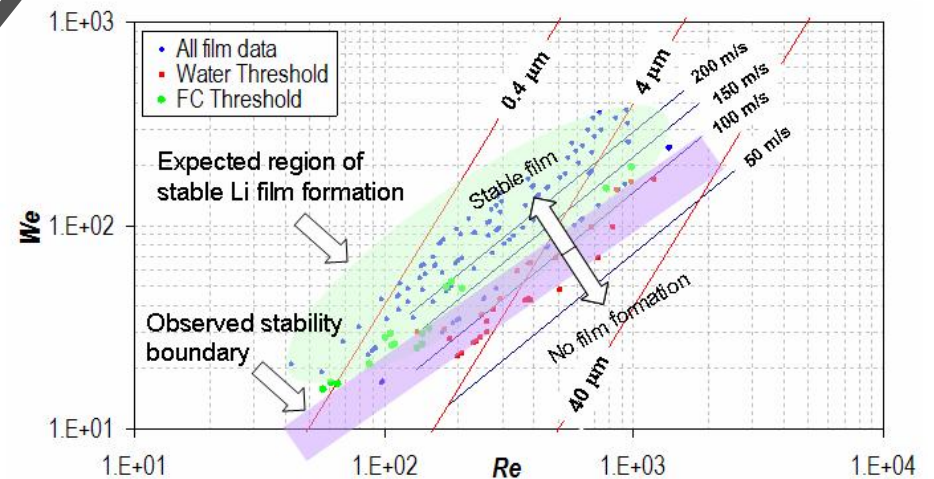


Figure 1. Schematic Representation of Stability Diagram for the Jet in Vacuum.



Introduction

Approach to thin film production

- Forces on flowing Li film in vacuum:
 - Inertia (IF)
 - Surface tension (SF)
 - Viscosity (VF)
- Reynolds number (Re) \sim IF/VF
- Weber number (We) \sim IF/SF
- Empirically determine film stability in We vs Re plane
- Use water & fluorinert to scope stable region

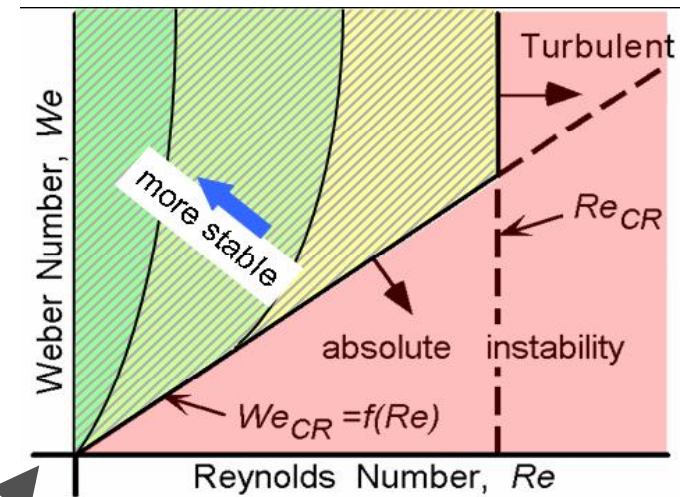
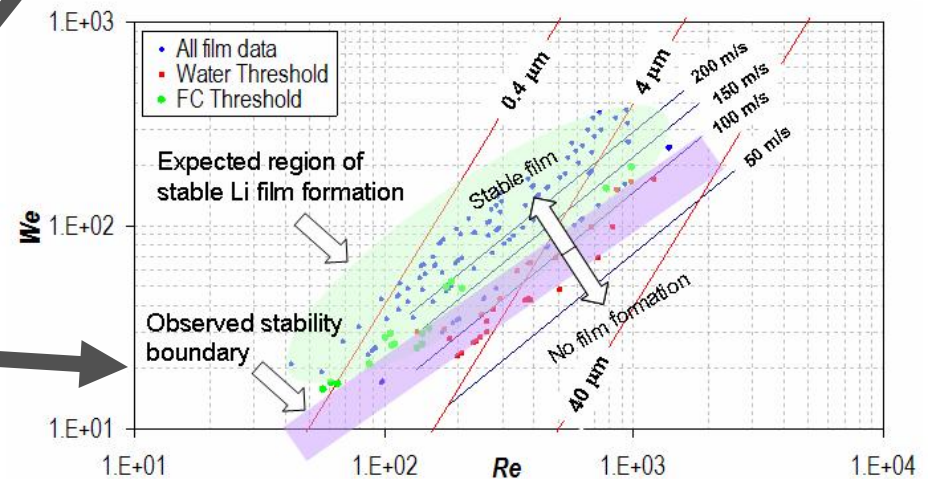


Figure 1. Schematic Representation of Stability Diagram for the Jet in Vacuum.

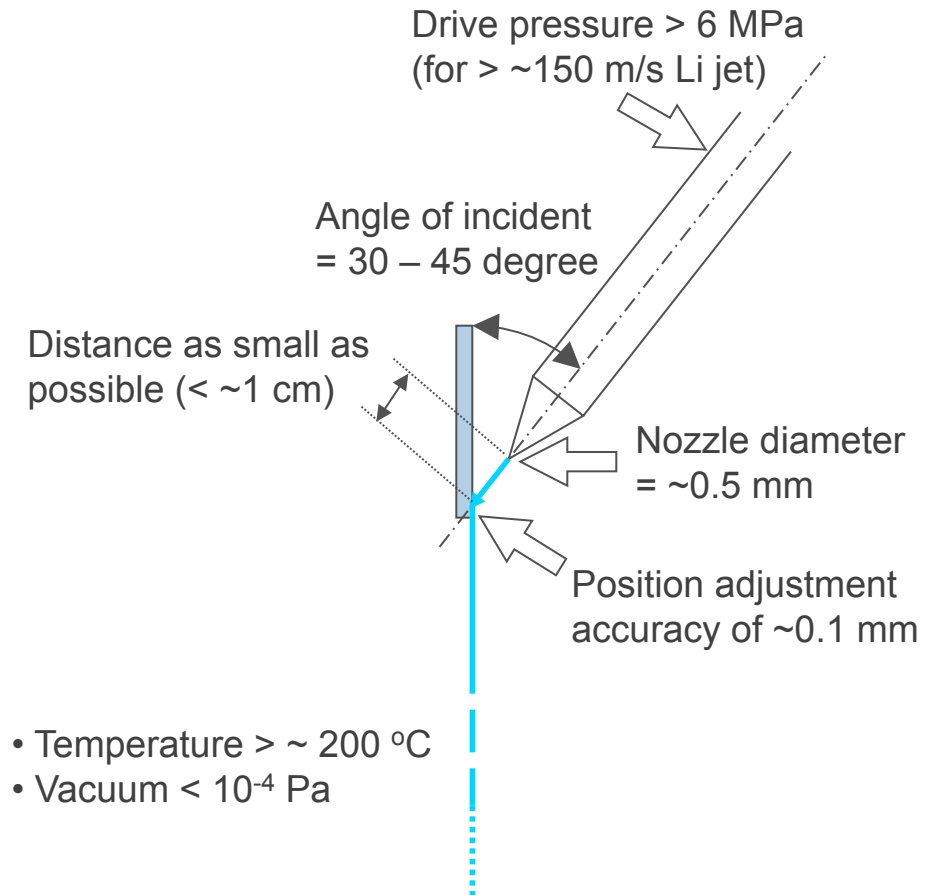
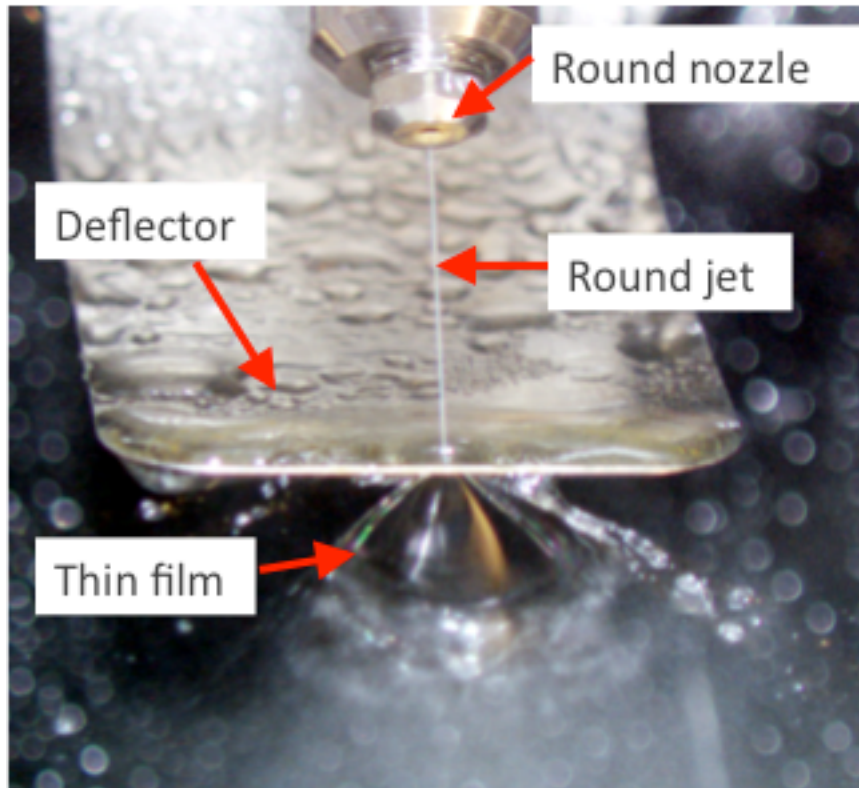


■ Demonstrate film in lithium

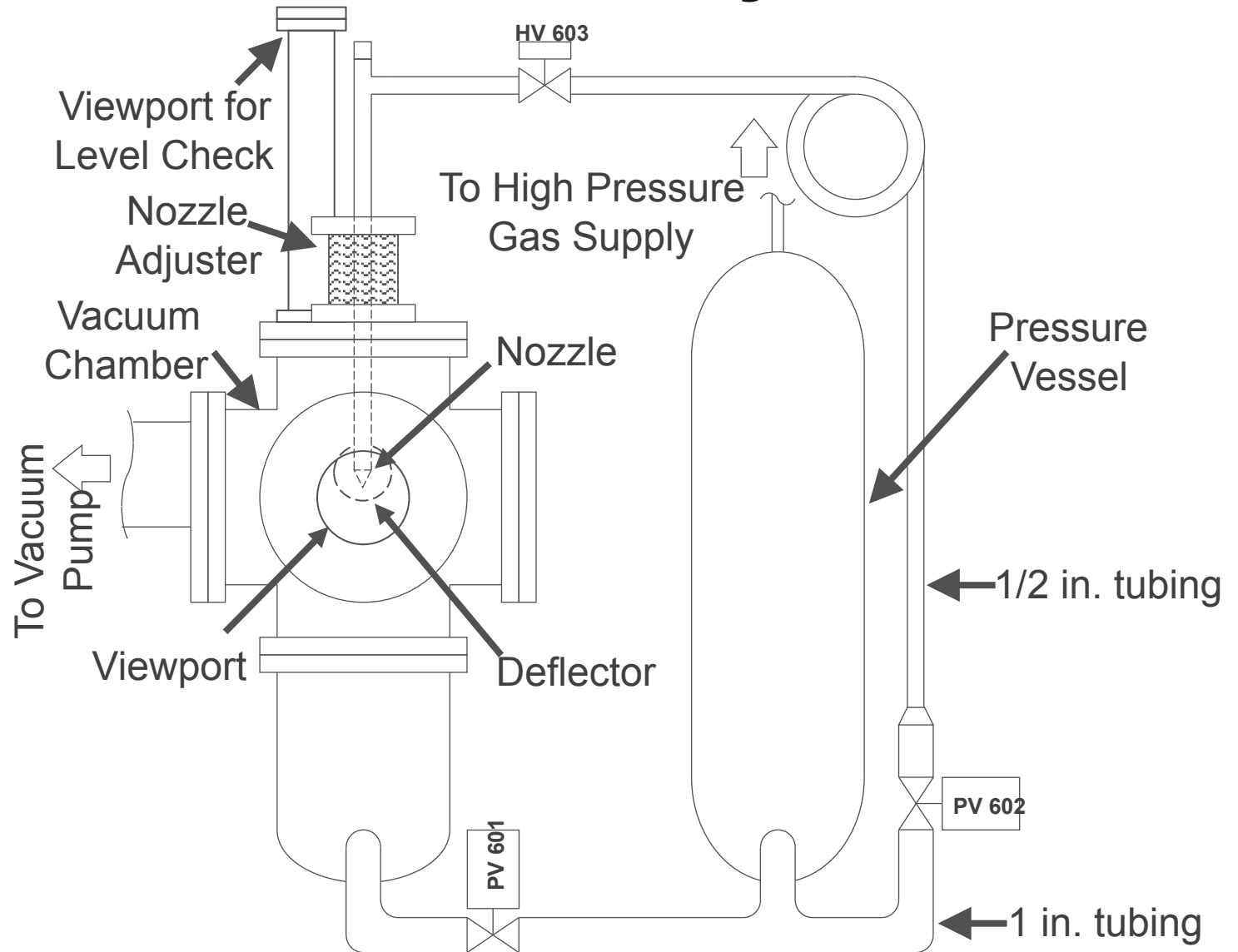


Thin film formation scheme & parameters

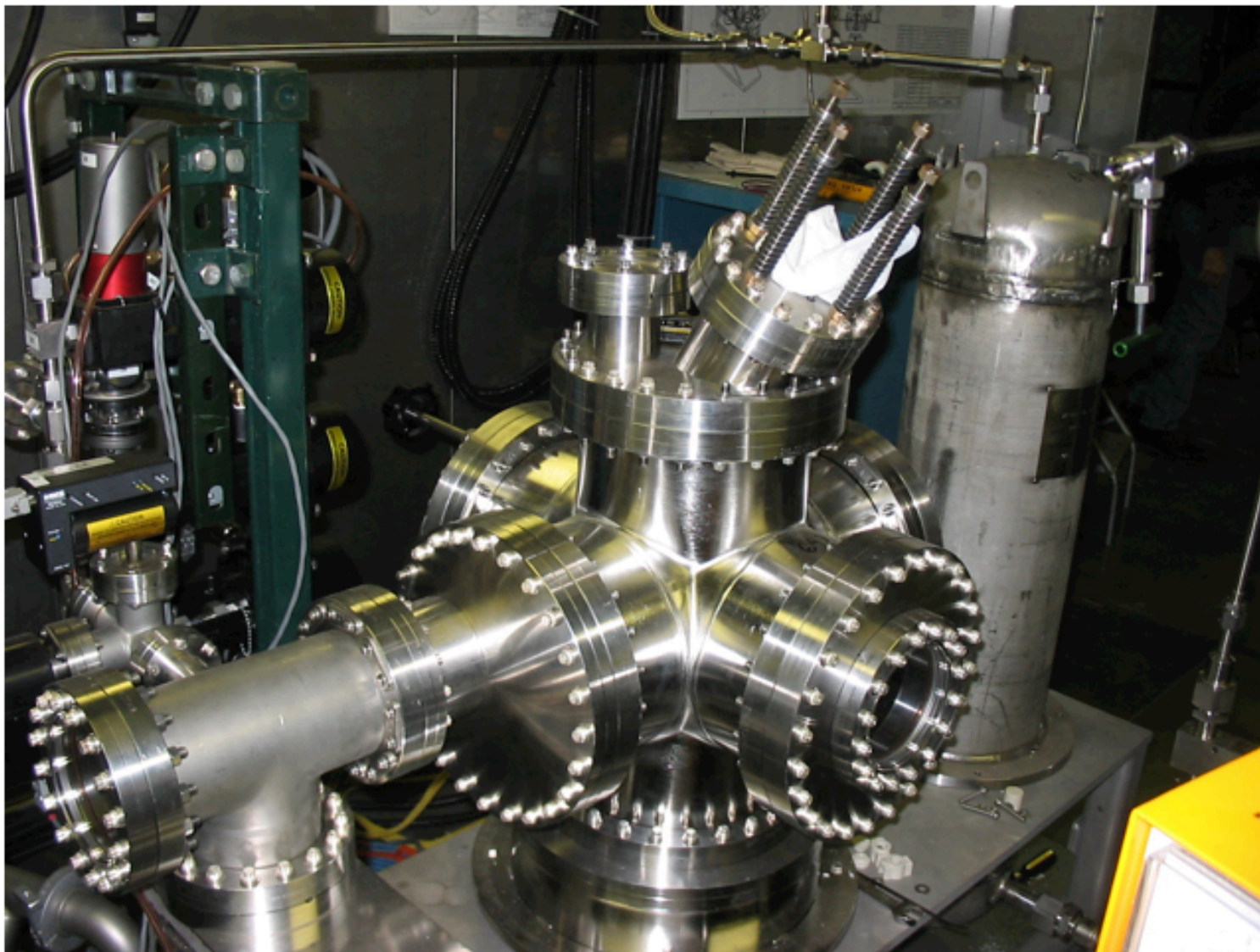
- Critical design parameters
 - Determined based on these 1st and 2nd phase experiments.



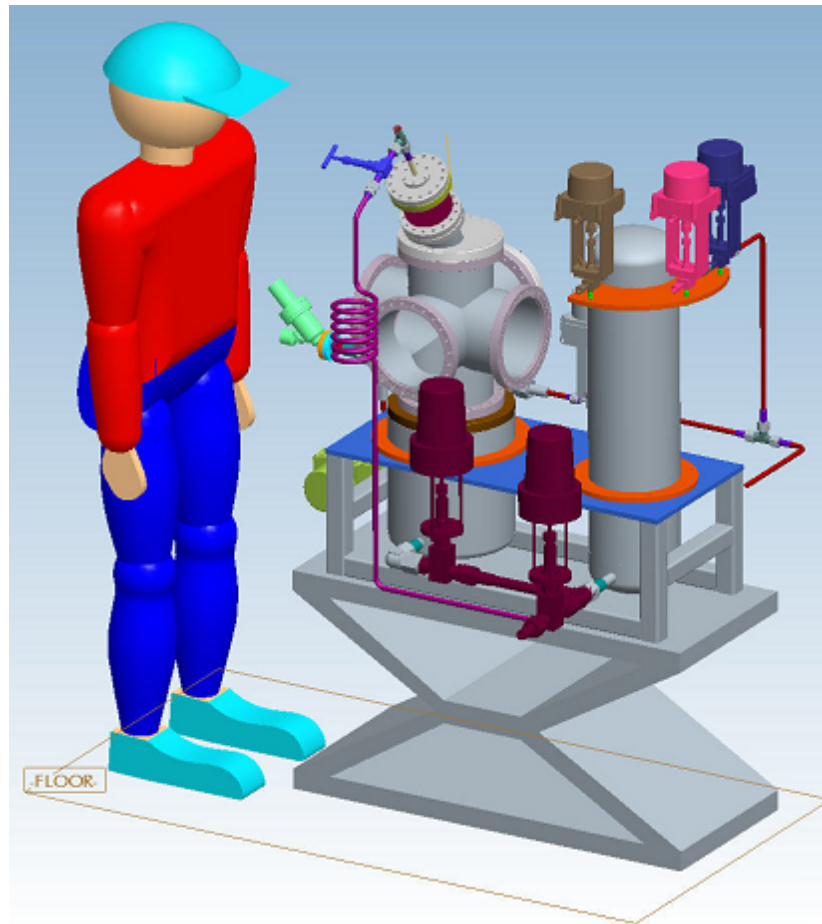
Schematic of Lithium System

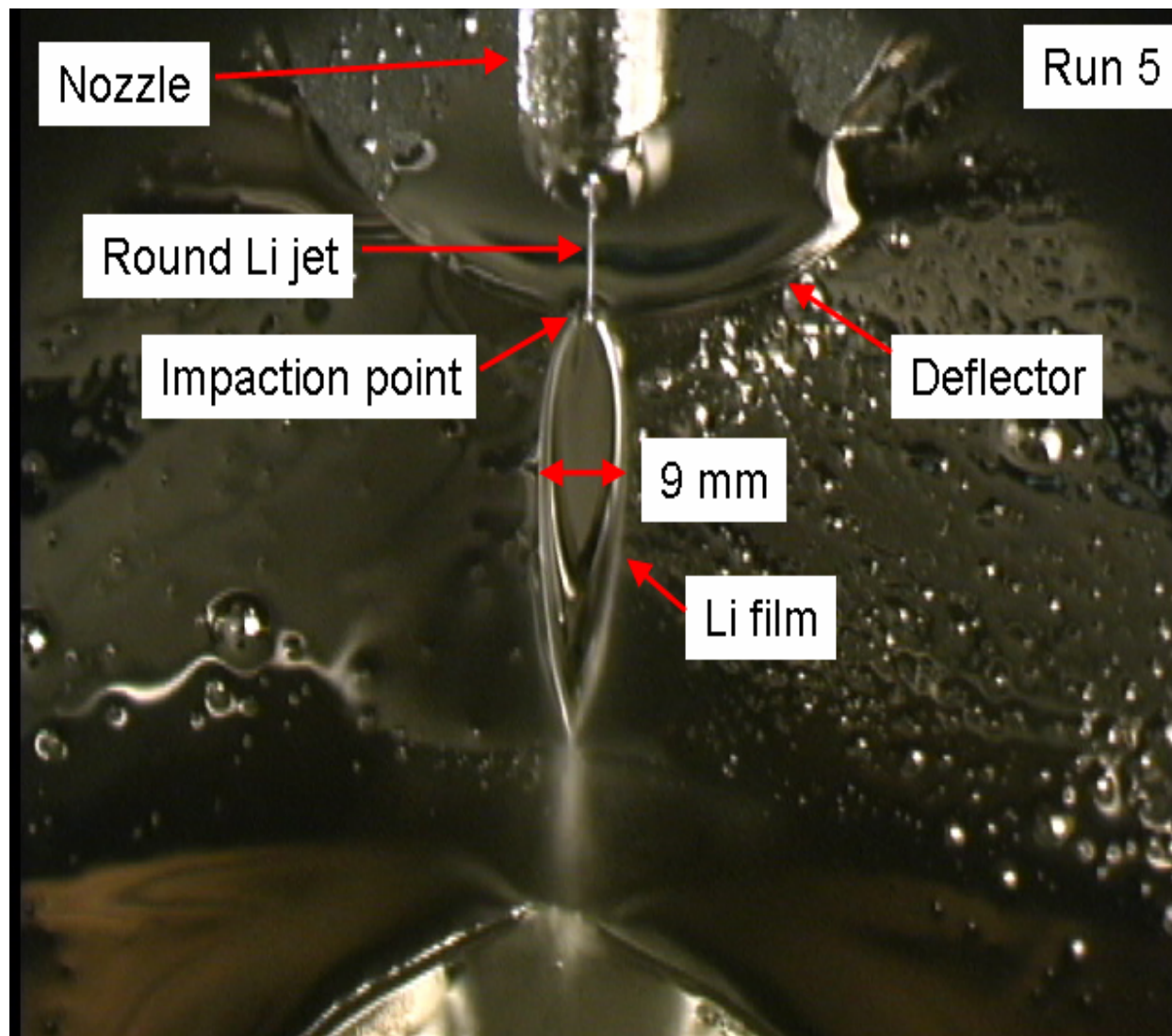


Old Li Stripper System



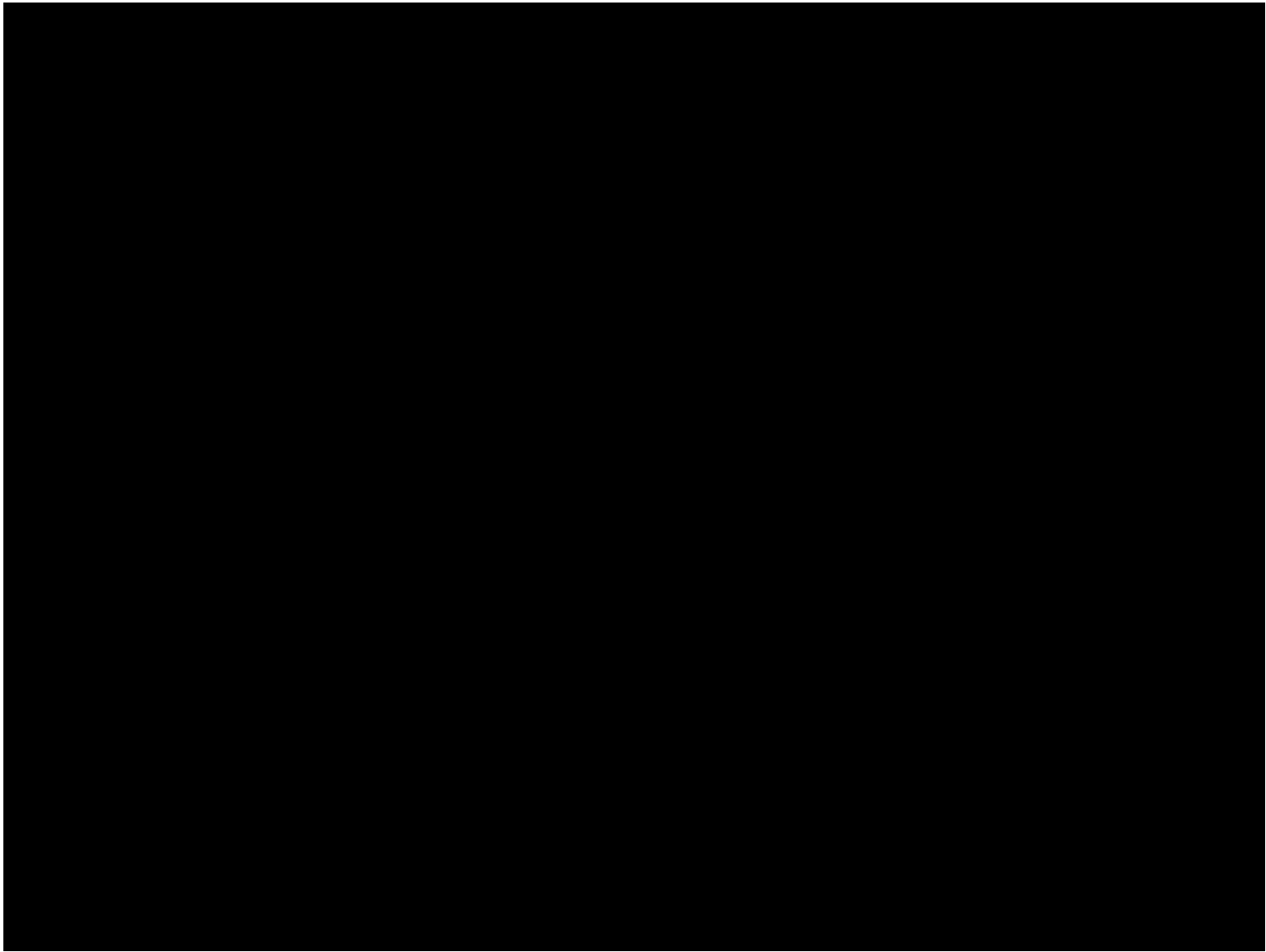
Approximate size of lithium stripper system





liquid lithium thin film

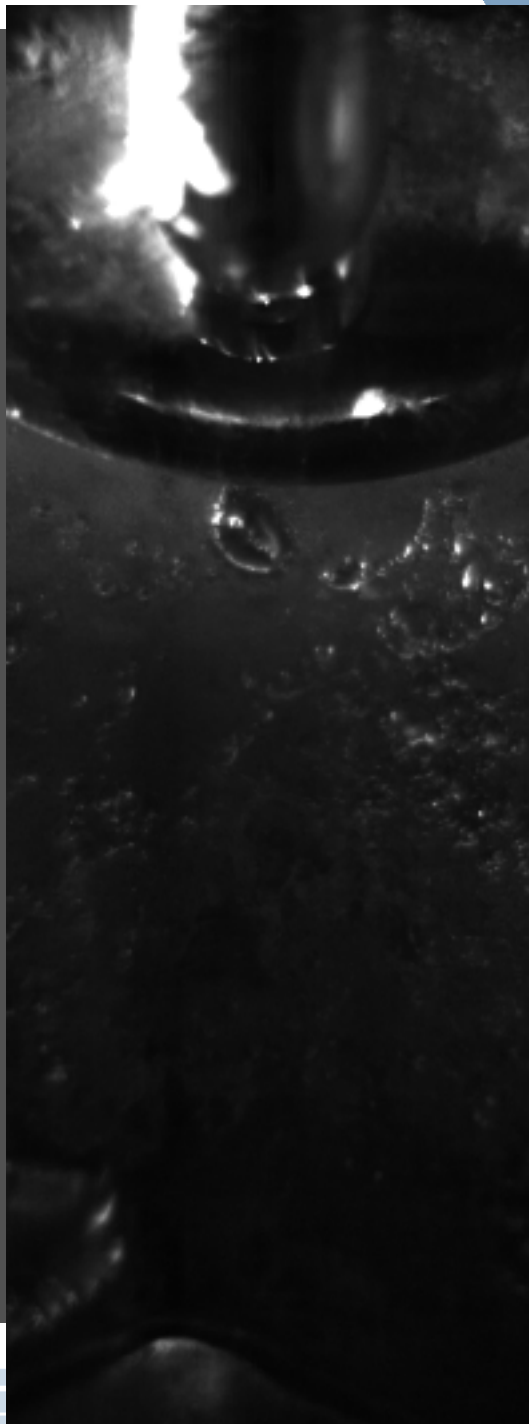




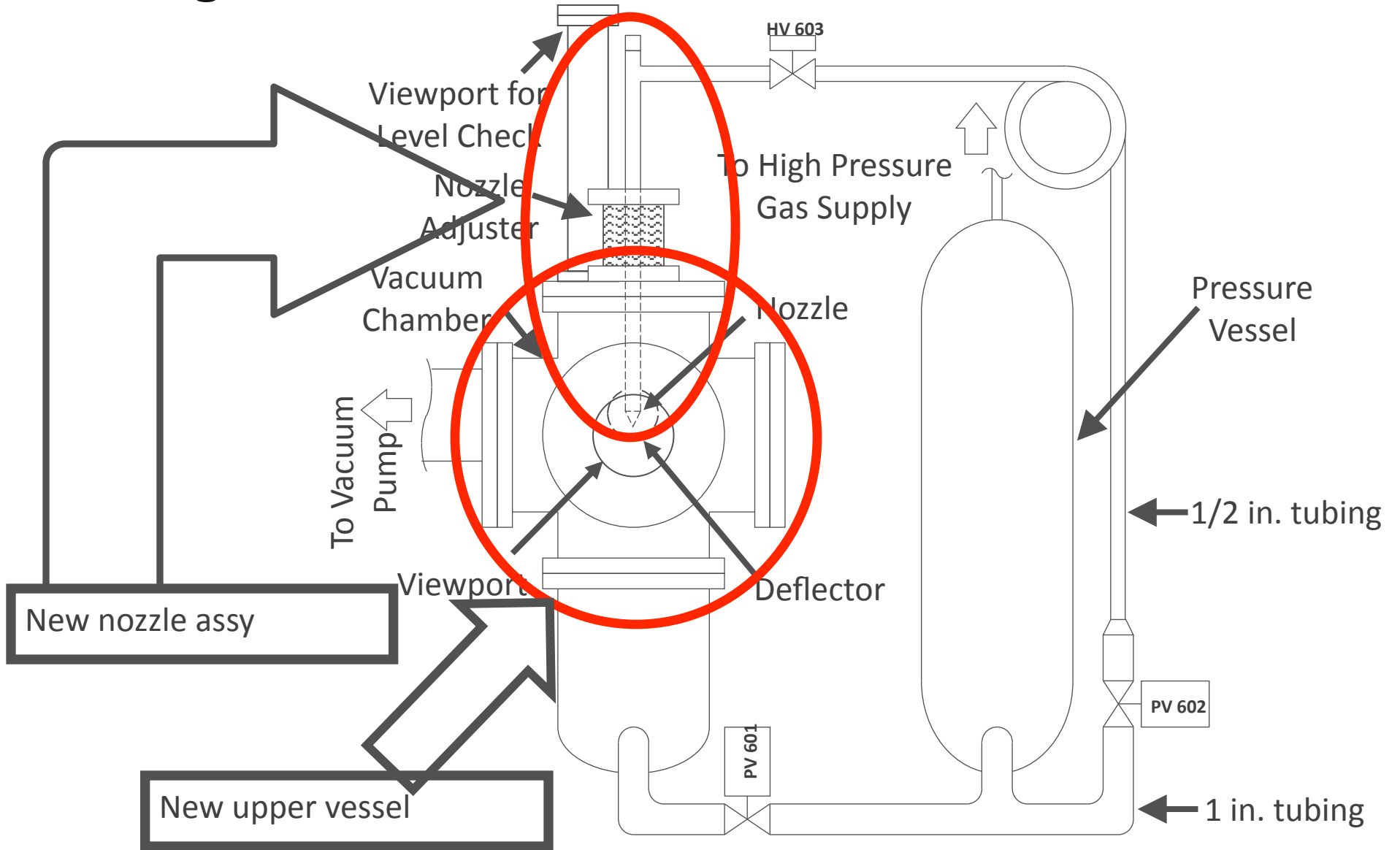
liquid lithium thin film



Record rate = 6,300 fps
Playback rate = 29.97 fps
Drive pressure = 2.8 MPa
Nozzle ϕ = 0.5 mm

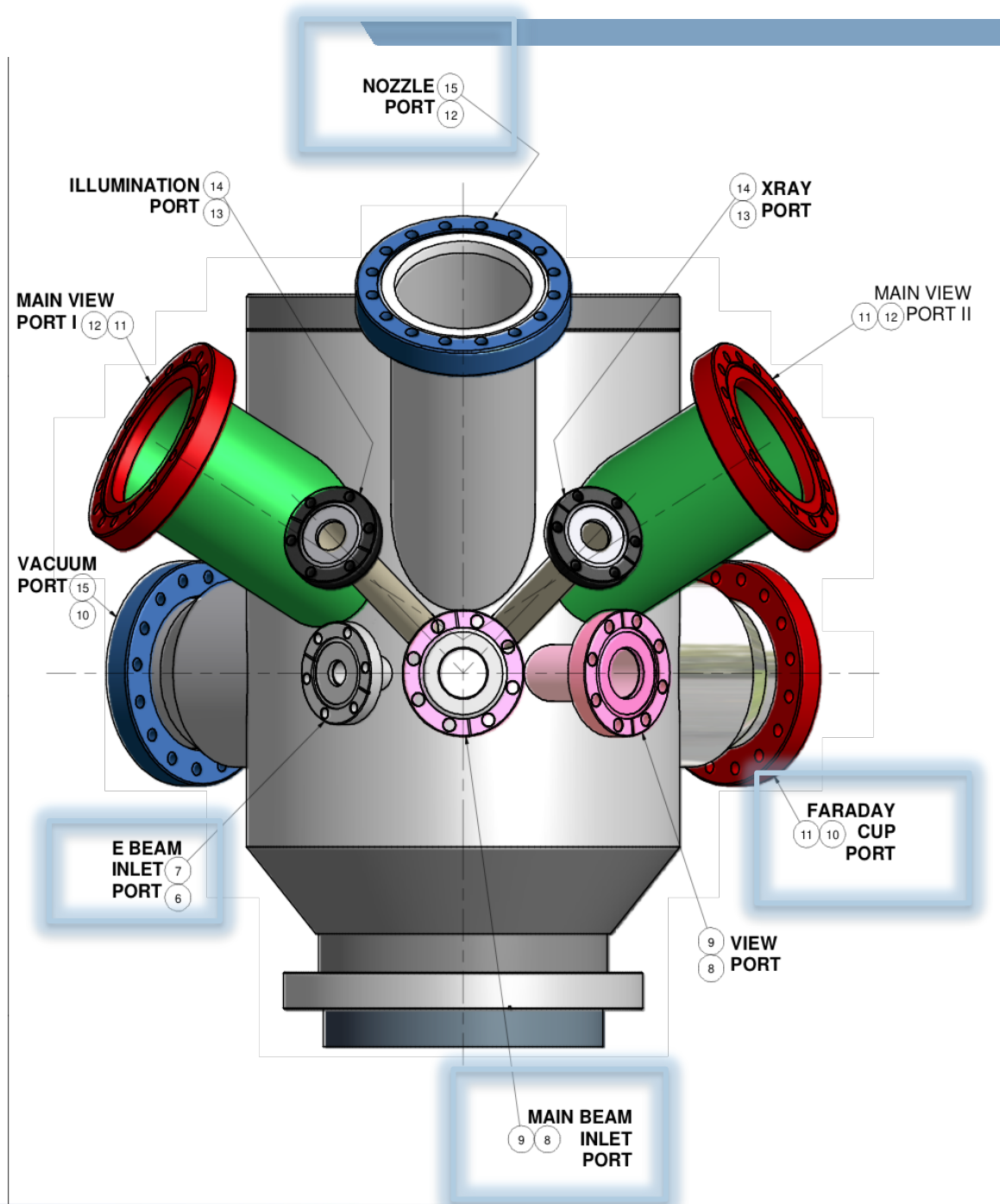


Changes for FRIB



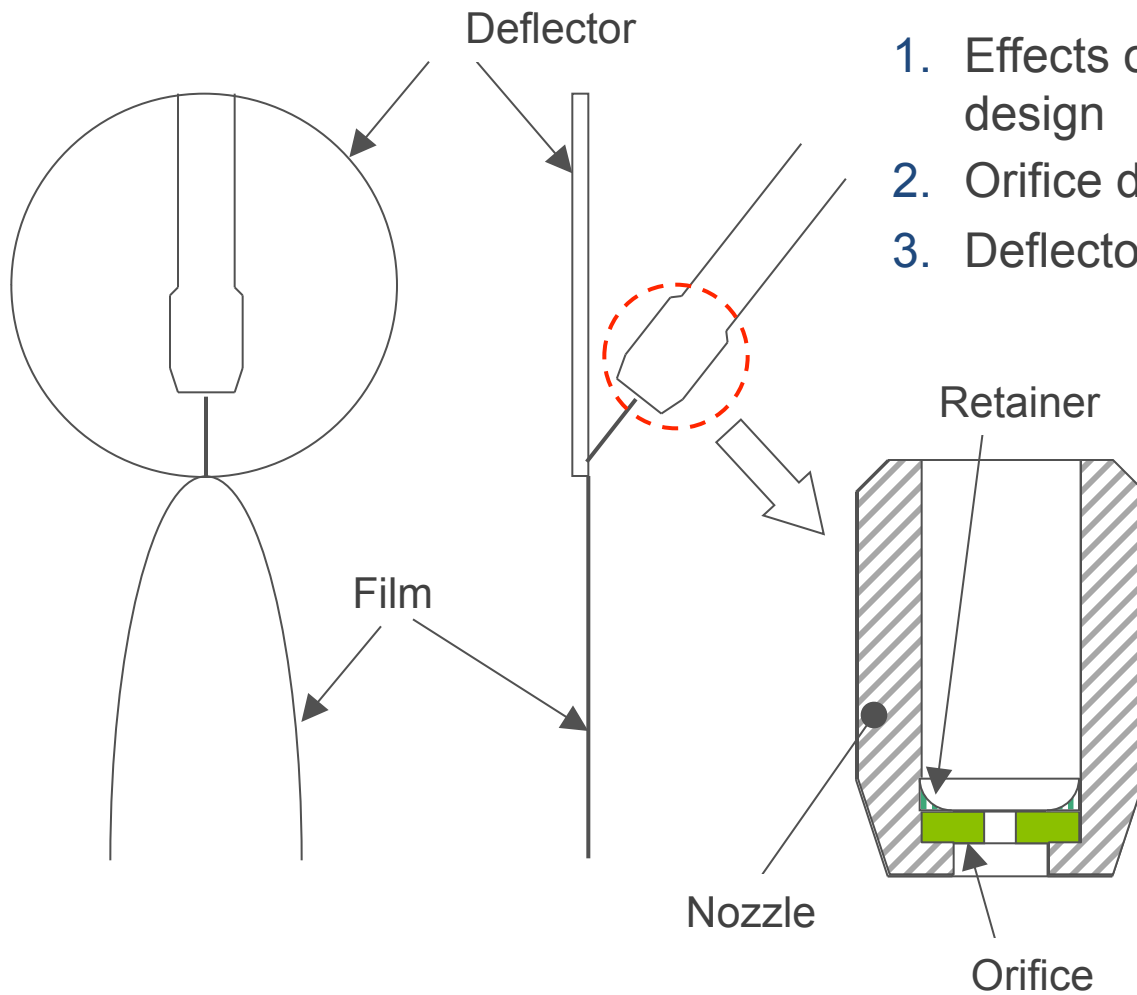
New Upper Vessel

- Upper vessel provides many ports to study and diagnose the liquid film
- View ports for visual observation



Film formation issues

- 3 fundamental issues

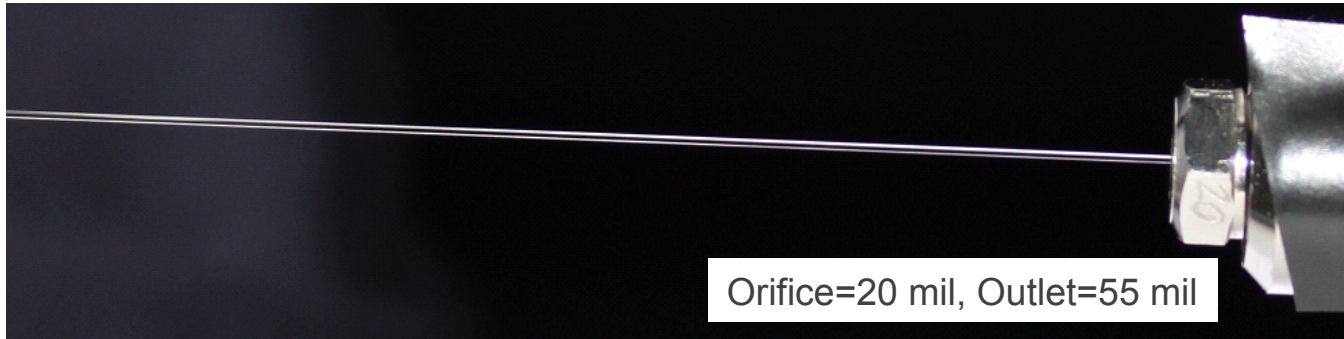


1. Effects of nozzle inlet and outlet design
2. Orifice design, material, and finish
3. Deflector design and finish

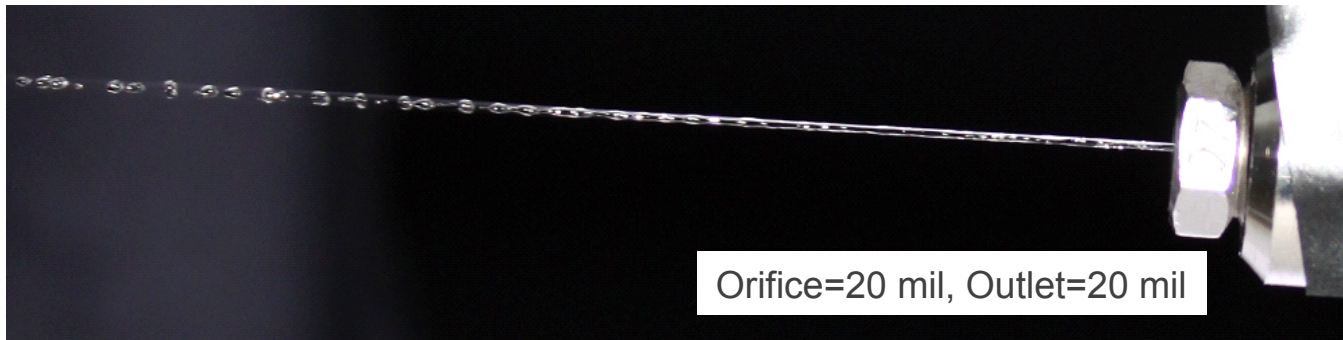


Nozzle development

- Effects of nozzle inlet and outlet design



20 mil Al₂O₃
File:100-265



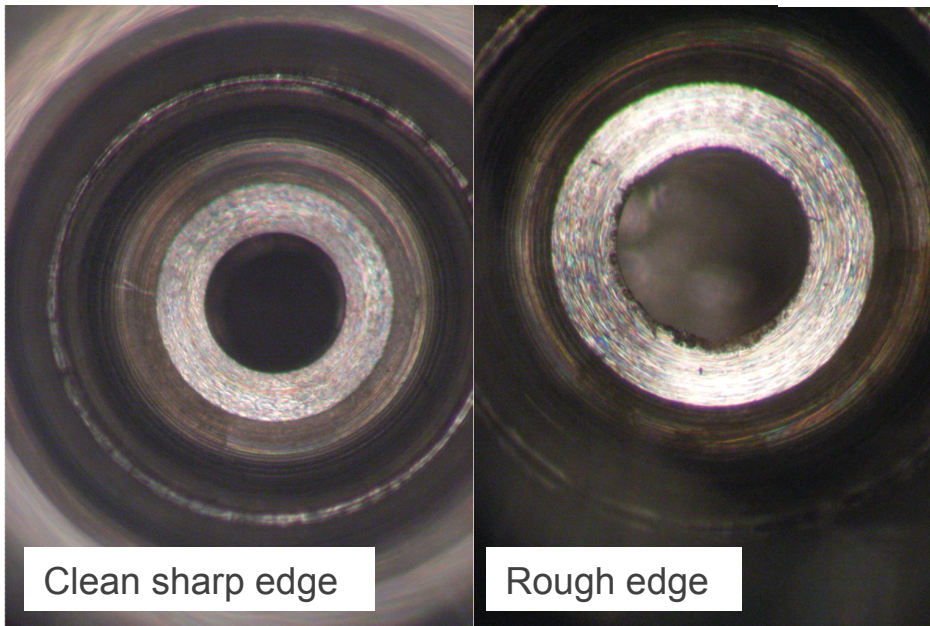
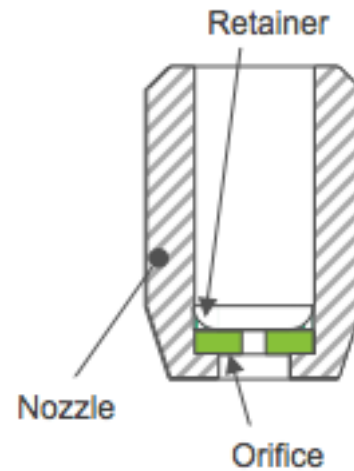
20 mil SS
File:100-275

10 psi



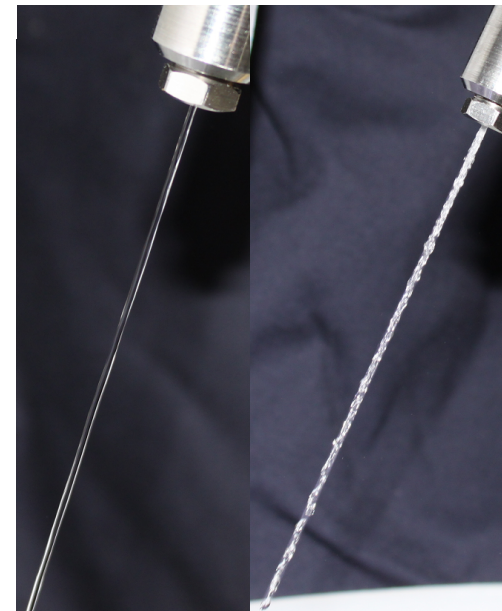
Nozzle development

- Orifice design, material, and finish
 - Well defined orifice
 - Stainless steel, orifice
 - Three-piece design



40-40 mil SS X

40-40 mil SS (2)



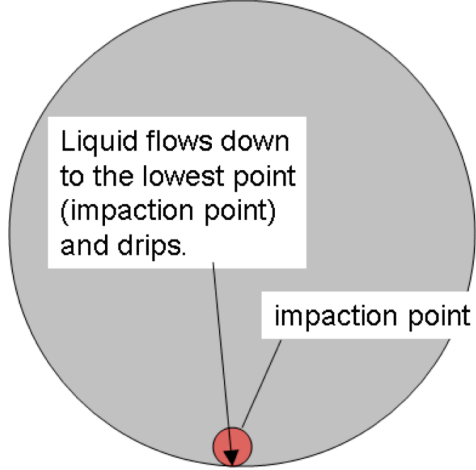
40-40 mil SS X
File:100-452

40-40 mil SS (2)
File:100-528

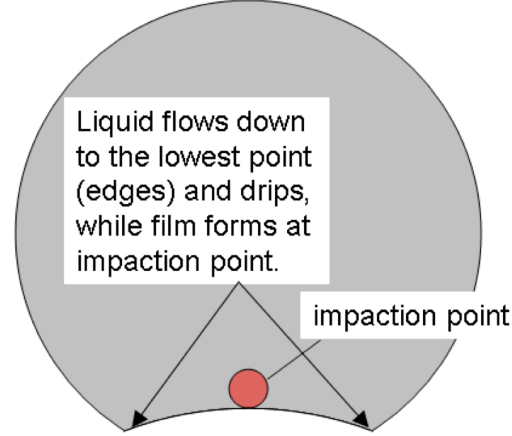
20 psi



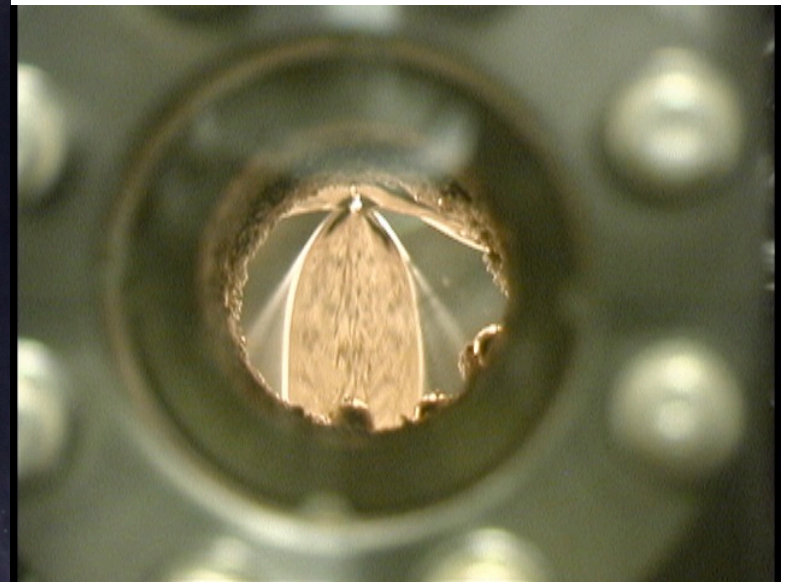
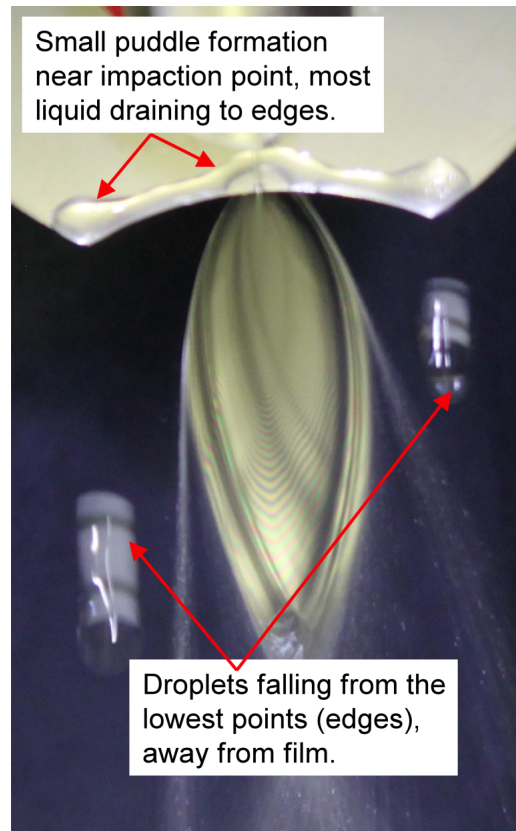
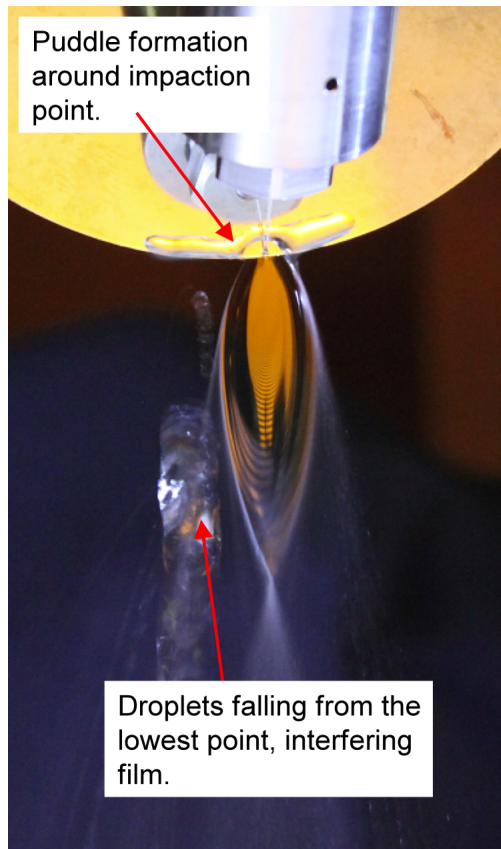
Deflector Issues



Old deflector



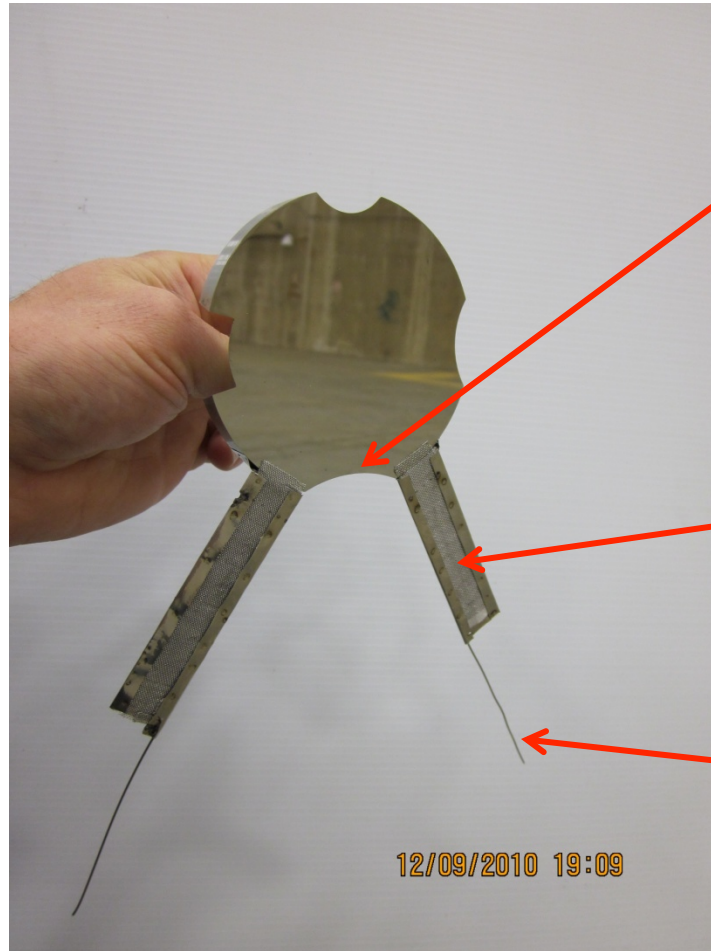
New deflector



Li Film



4-Profile Deflector With Wicks



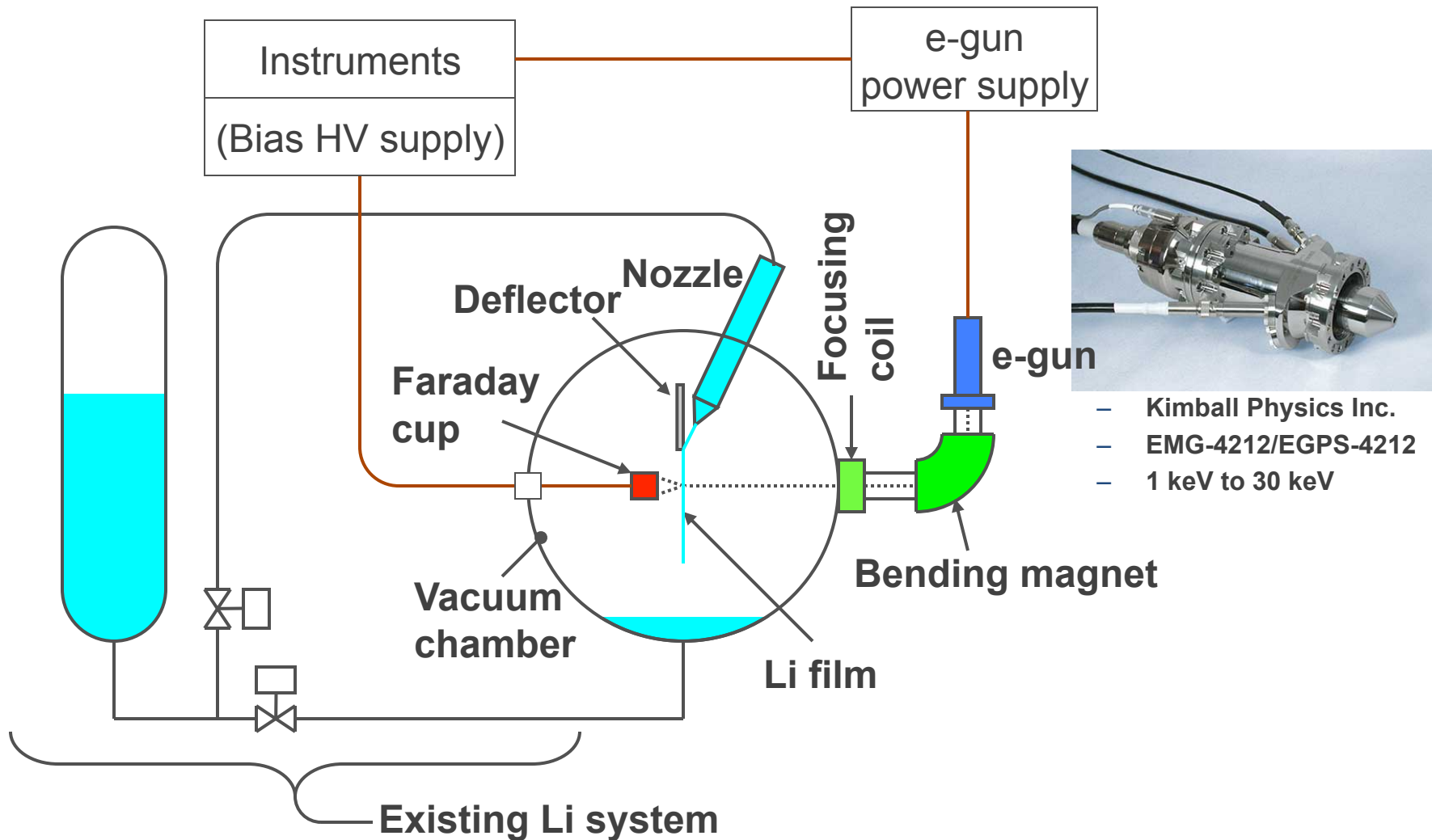
1 μ diamond polish on face and both sides of knife edge

Stainless steel mesh wicking to “pull” Li from deflector face and reduce puddling

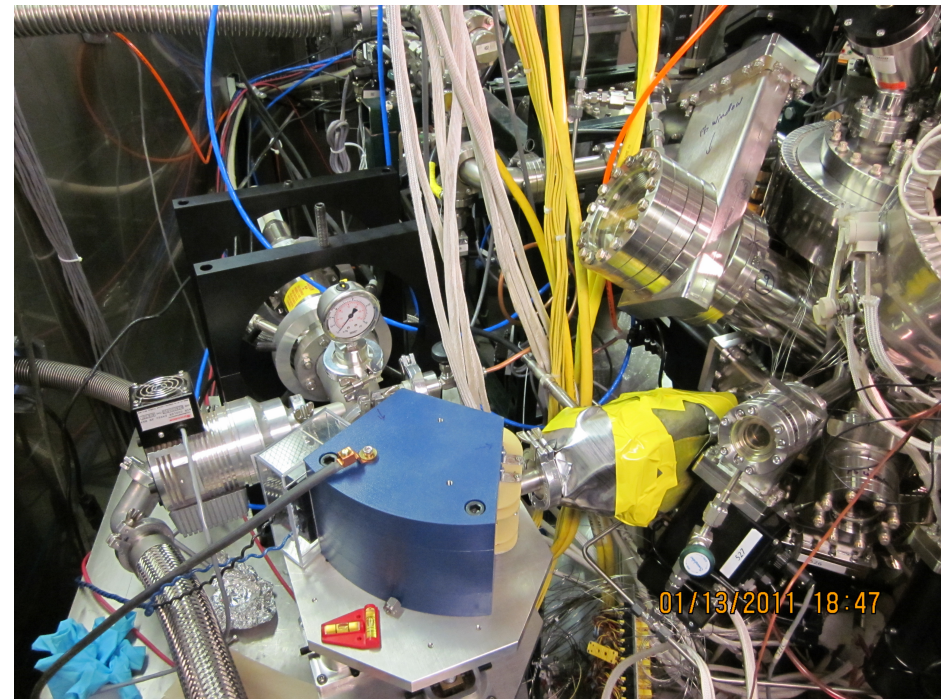
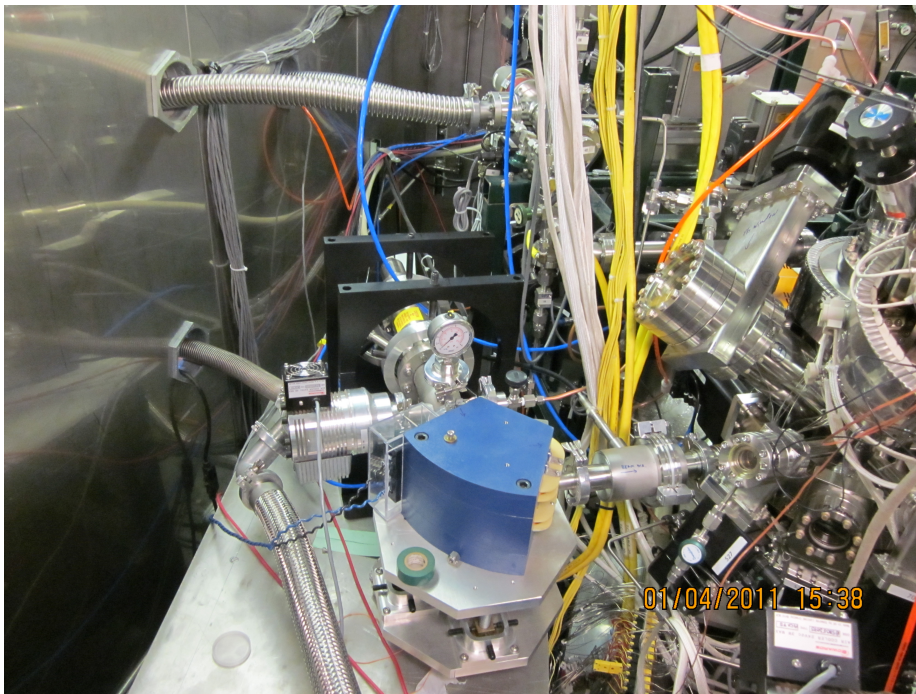
Stainless steel wire to guide Li droplets down and away from film

EMS system and operation

- System layout

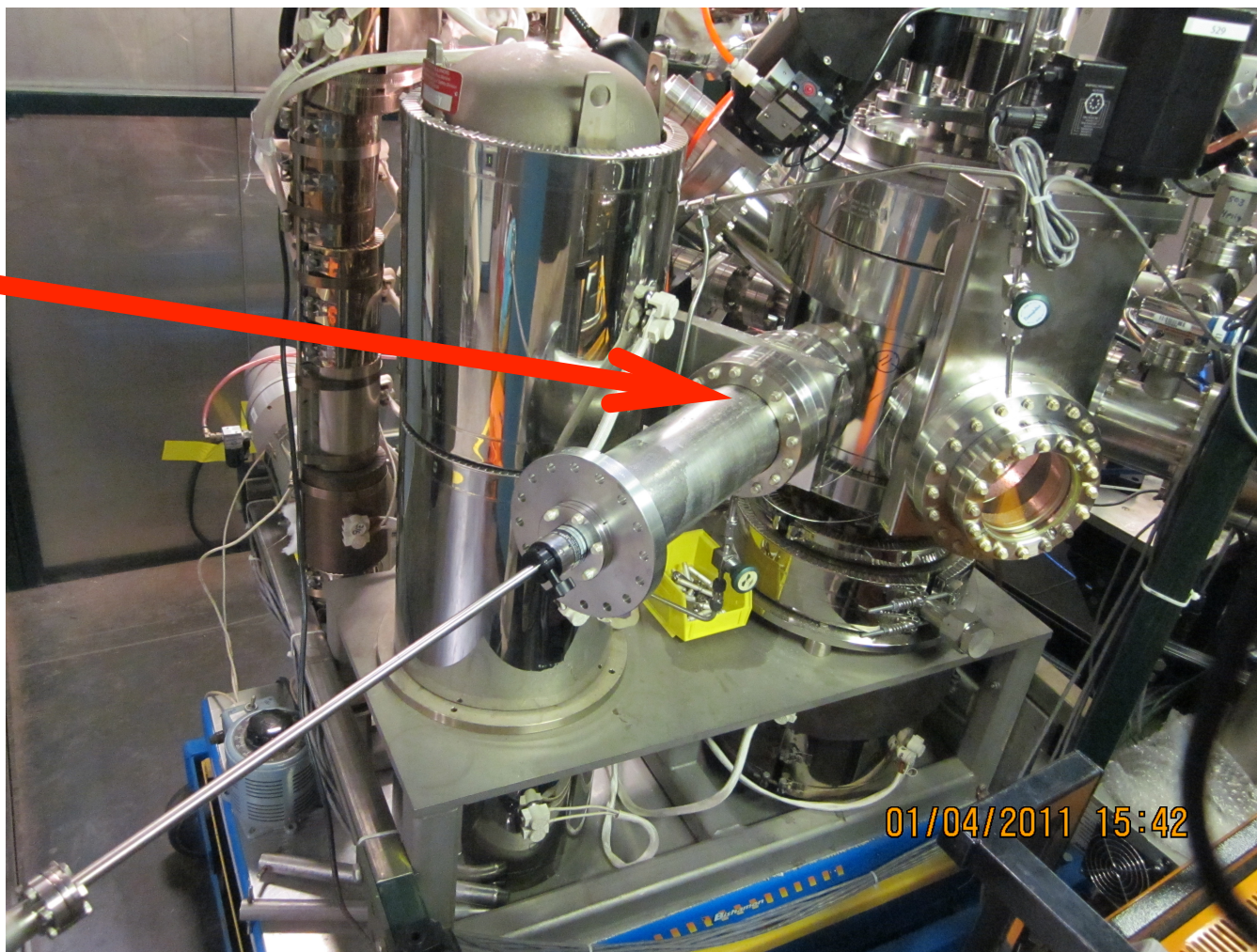


E-GUN SYSTEM INSTALLED ON LI VESSEL



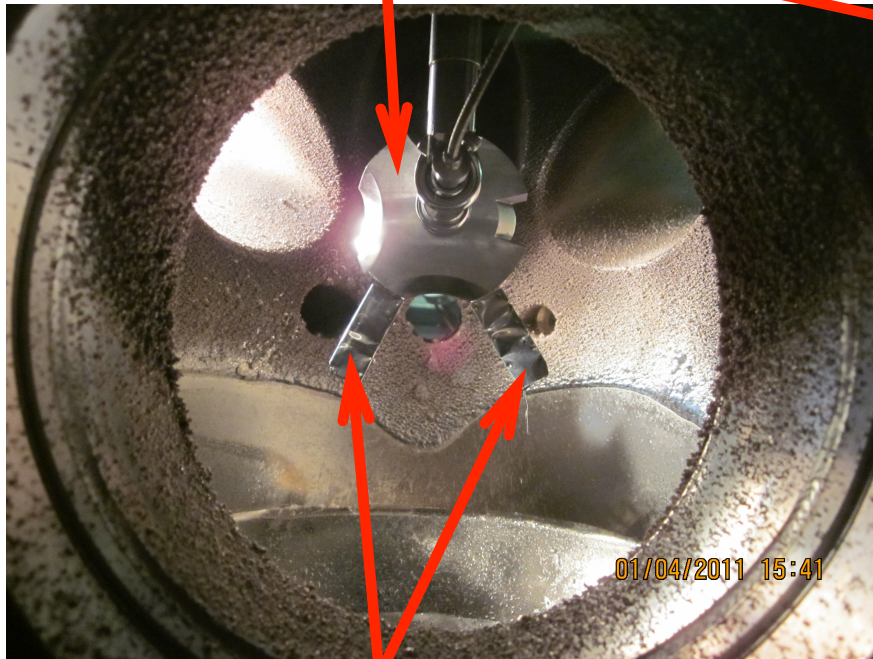
FARADAY CUP

Faraday
Cup

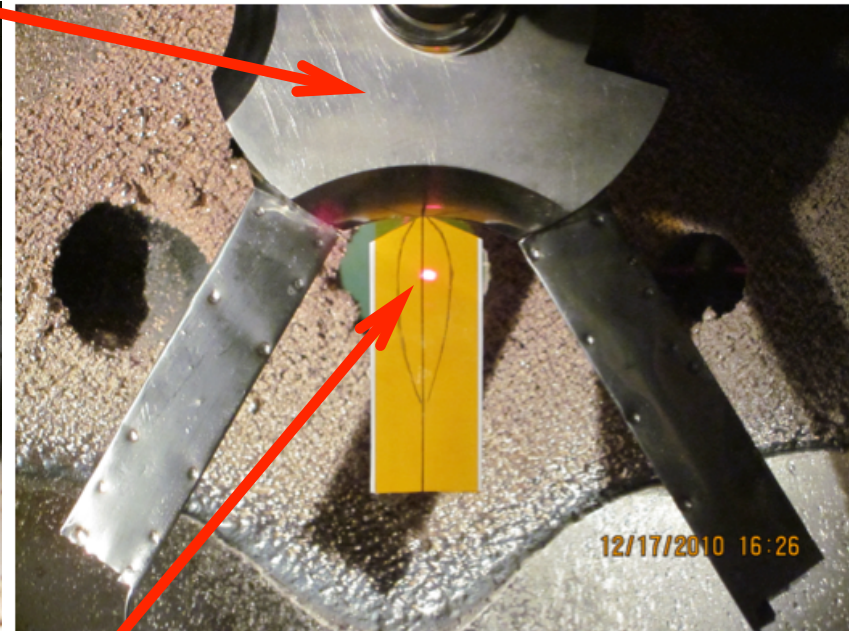


CUSTOM LASER ALIGNMENT DEVICE HELPS POSITION DEFLECTOR

Deflector



Wick Structures



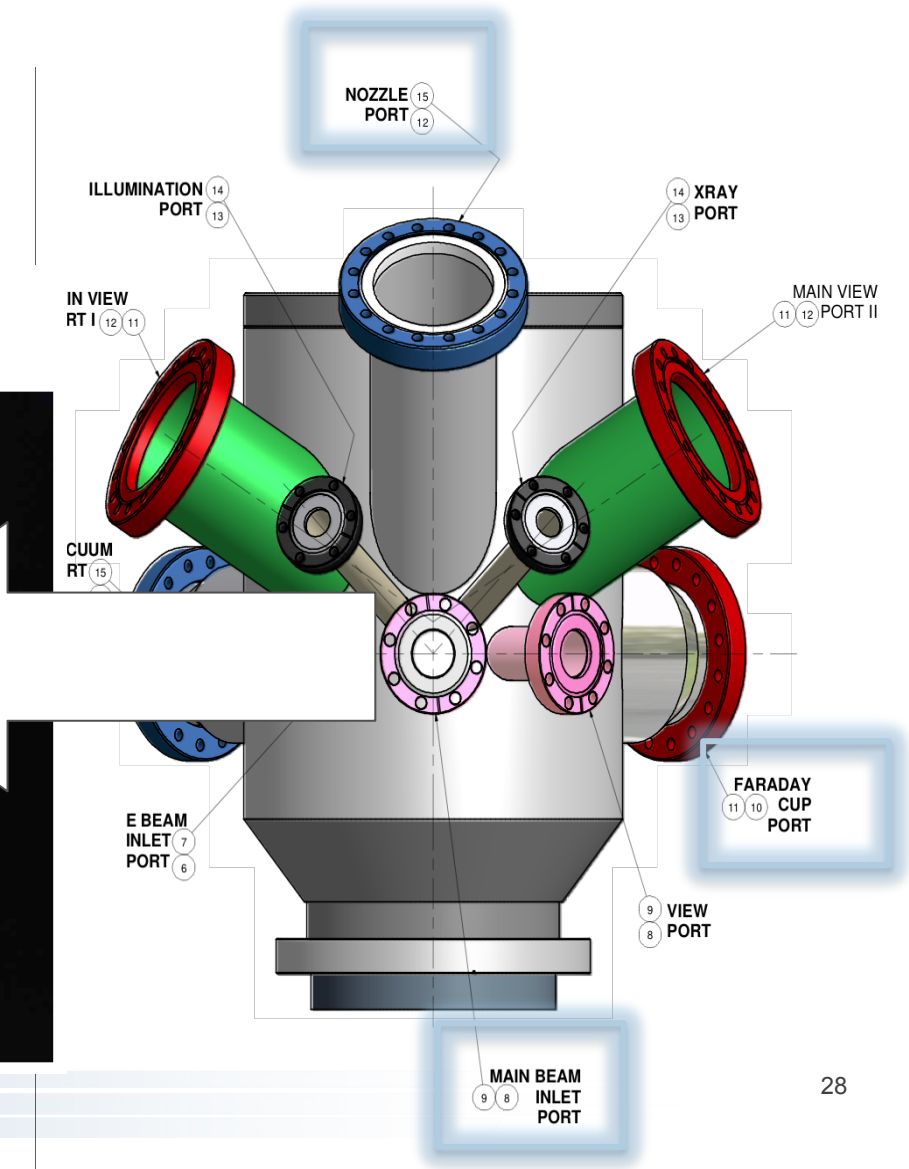
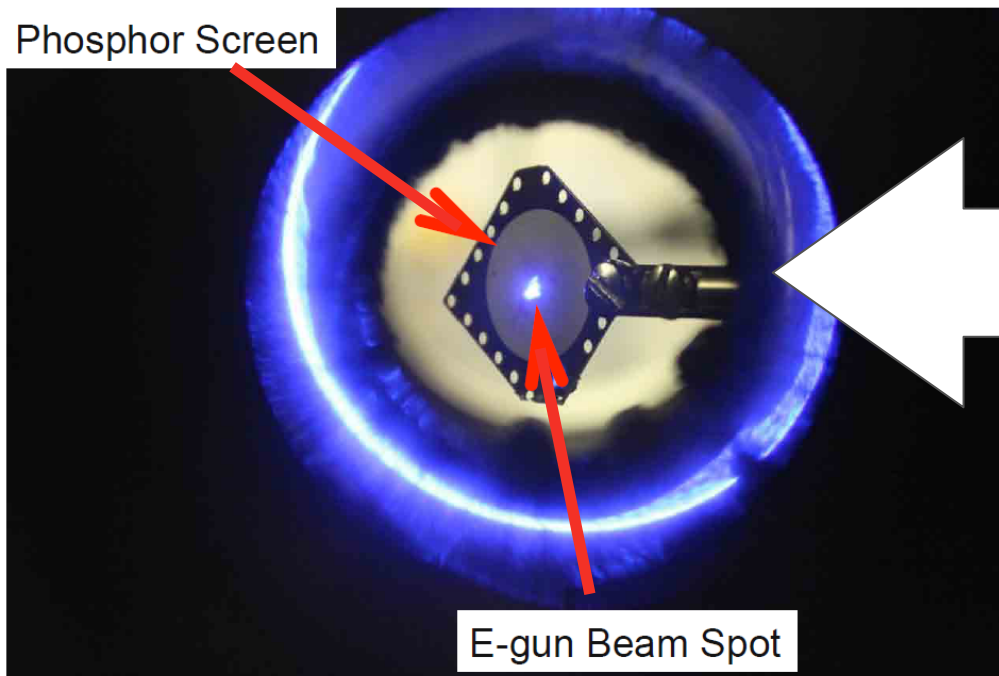
Alignment Laser Beam Spot



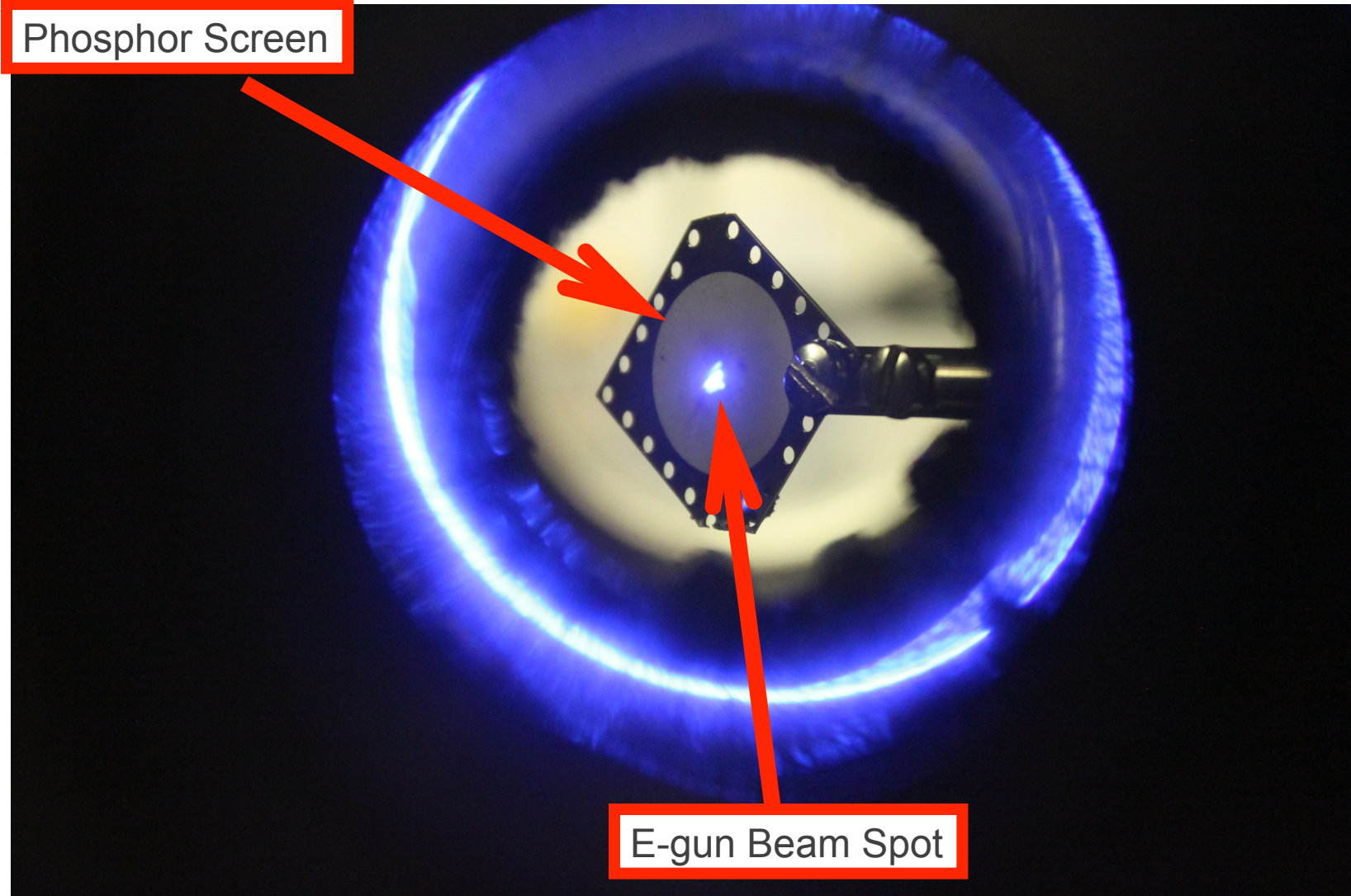
Electron Beam Alignment

- The electron beam gun is aligned at the position of the lithium film with the temporary installation of a phosphor screen

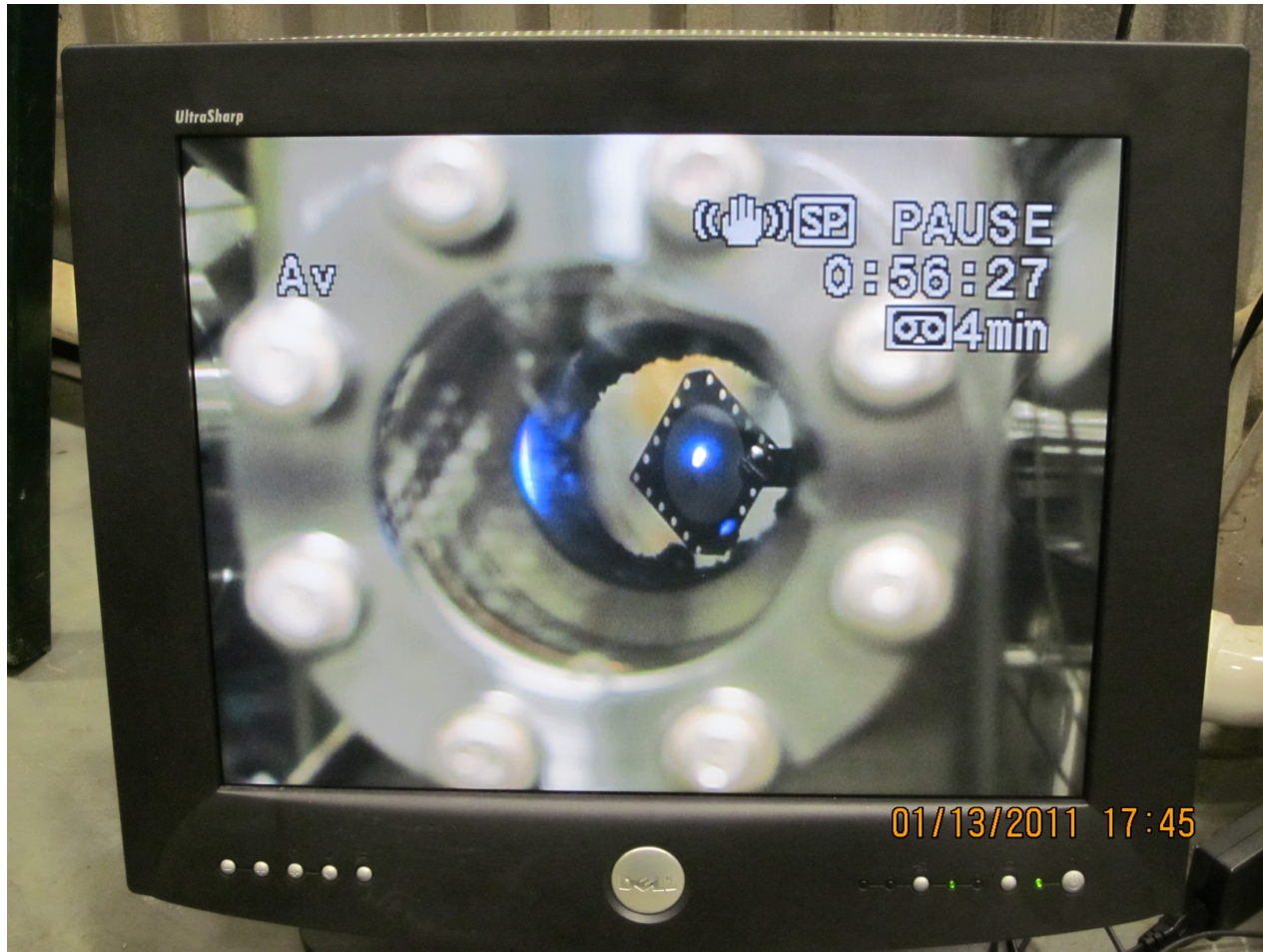
E-BEAM ON PHOSPHOR SCREEN
(looking through ion beam port)



***E-BEAM ON PHOSPHOR SCREEN
(looking through ion beam port)***



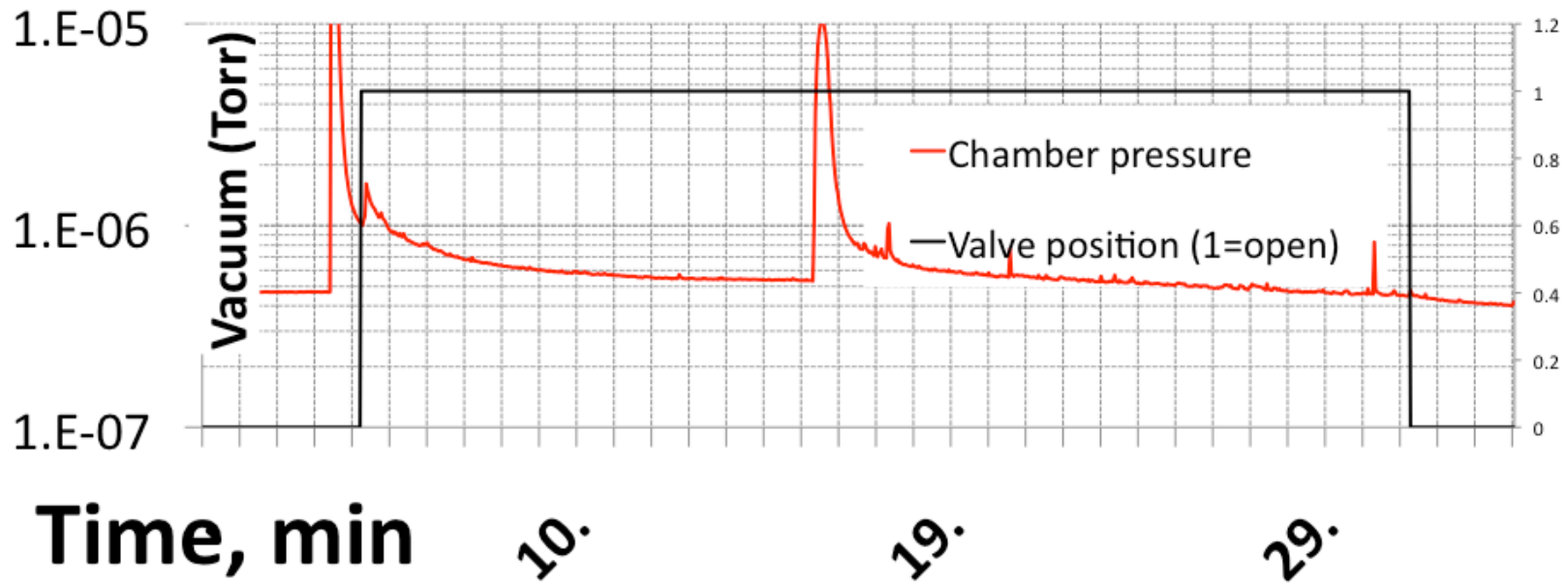
REAL TIME REMOTE S-VIDEO SCREEN IMAGES 4 MULTI-MEGAPIXEL DV CAMERAS



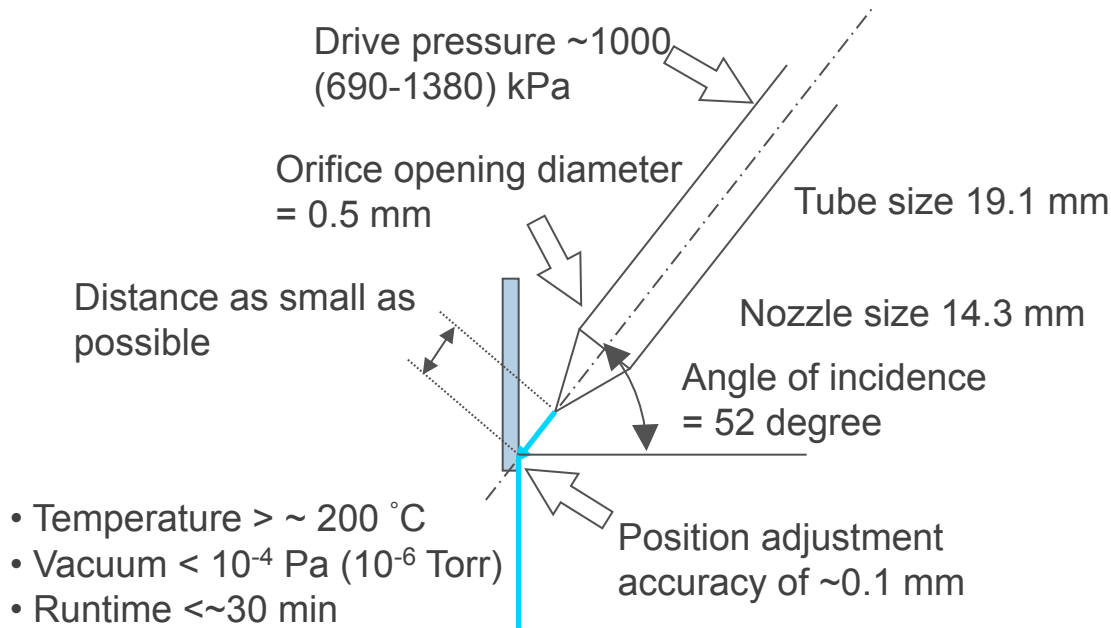
***REAL TIME REMOTE S-VIDEO SCREEN IMAGES
4 MULTI-MEGAPIXEL DV CAMERAS***



Stripper Chamber Vacuum Level



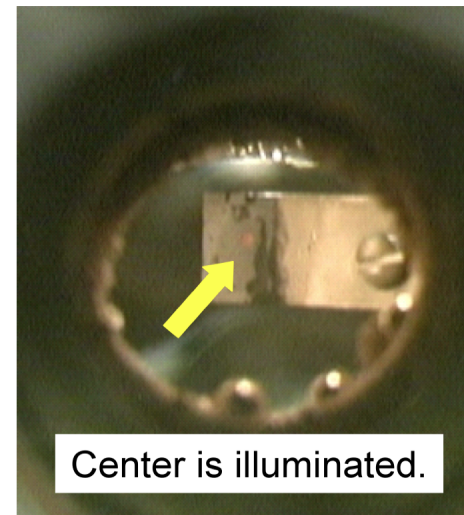
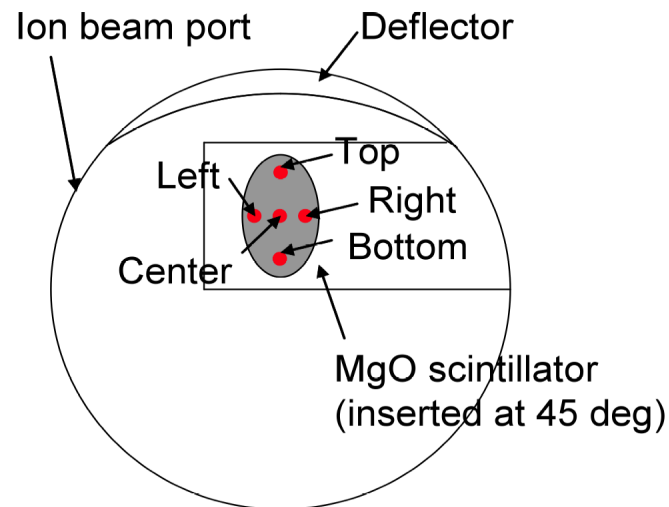
Operating conditions, experimental parameters



Operation parameters	
Li temperature	220 °C
Drive pressure	550 - 1380 kPa
Estimated Li velocity	46 - 73 m/s
Angle of incidence	52±0.2 °
Nozzle size	14.3 mm
Orifice opening size	0.5 mm
Deflector type	Type 1 & 2

Thickness Measurement Result

- $632 \pm 35 \mu\text{g}/\text{cm}^2$
- $\pm 5.5\%$ for 1 mm spot diameter
- Physical thickness $12.3 \pm 0.7 \mu\text{m}$





Next Steps

1. Ion beam on Li film
2. dc ~110 mA ion source from LANL
3. 75 keV
4. ~ 1kW to be deposited in Li film





Beta-beams

**Very preliminary discussions with
beta-beam collaboration**

